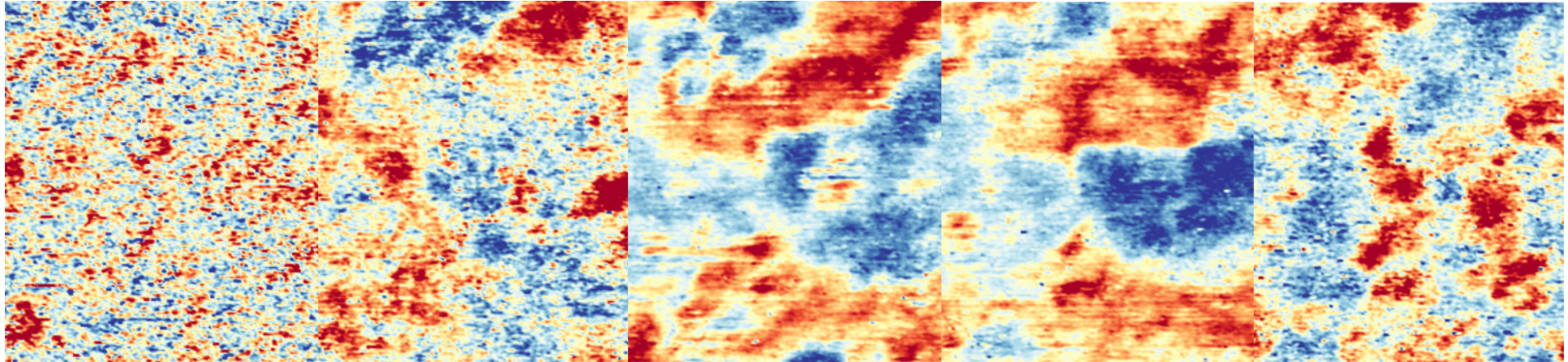


# Graphene at the local scale: charge disorder, screening and work function

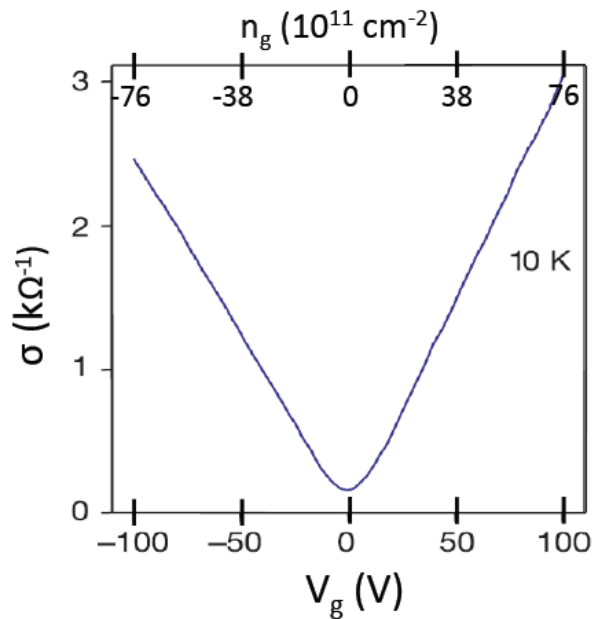
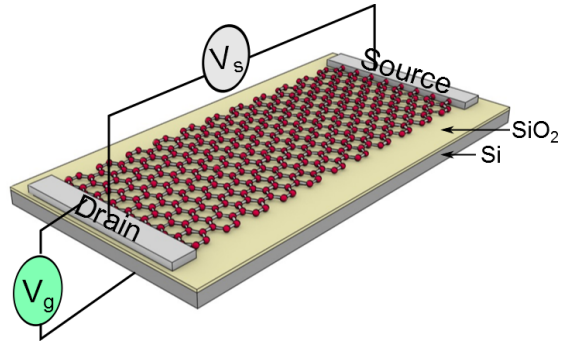


*Clemens Winkelmann*  
*QNES, Institut Néel*

*GDR Physique quantique mésoscopique*  
*Aussois, 8 December 2016*

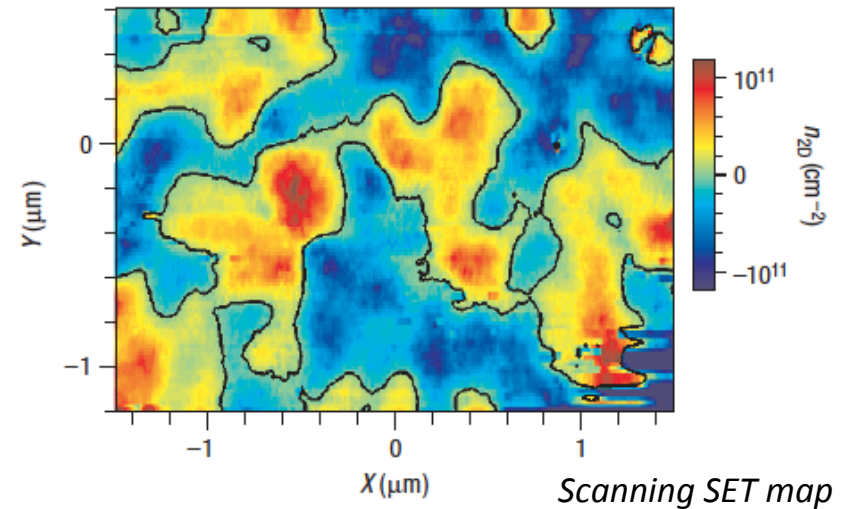


# Charge disorder in graphene on SiO<sub>2</sub>



Novoselov *et al.*, Science (2004)  
Chen *et al.*, Nat. Phys. (2008)

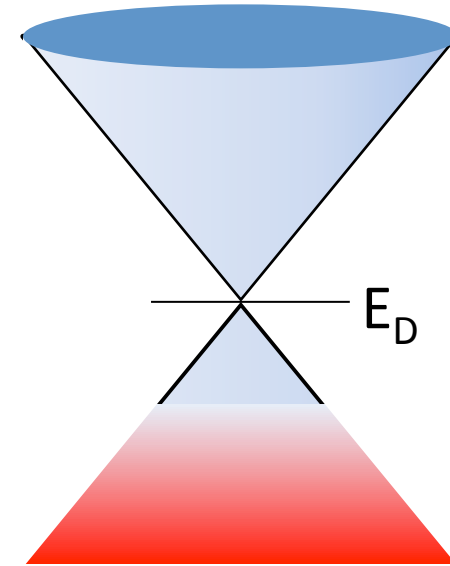
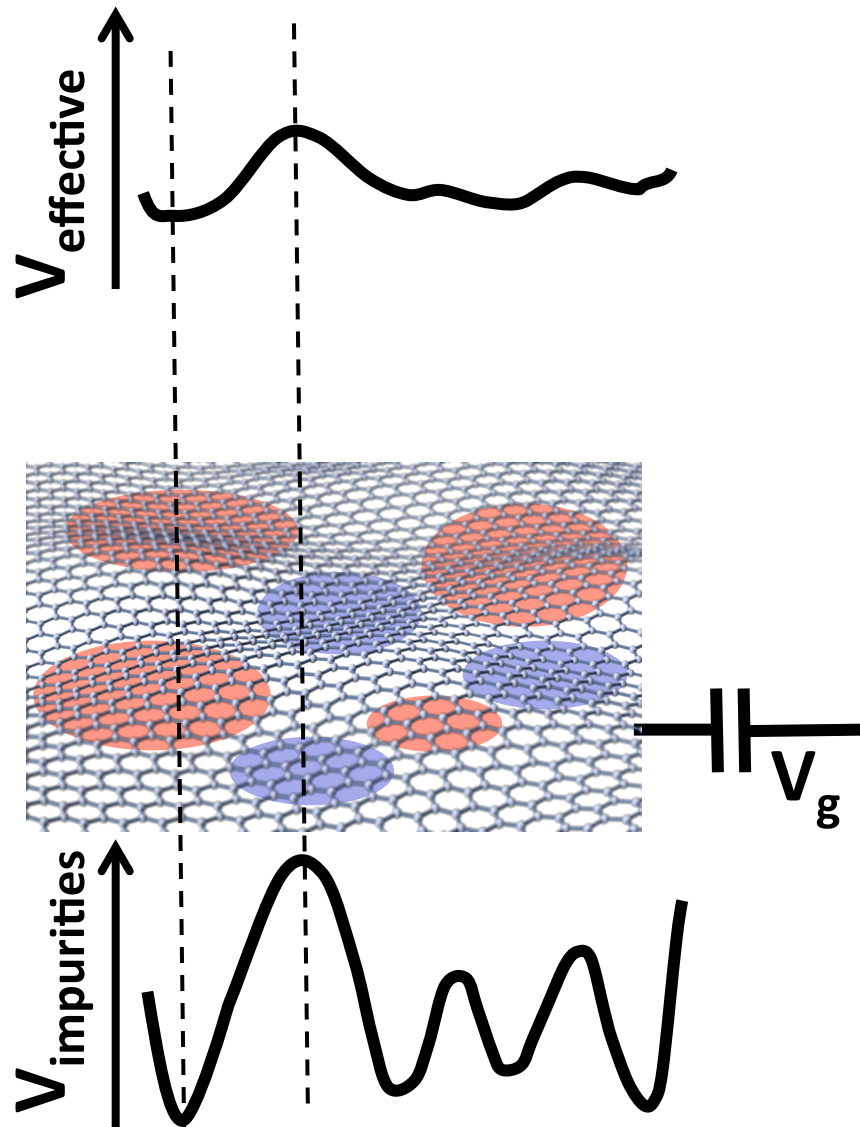
## Charge density inhomogeneities (puddles)



J. Martin *et al.*, Nat. Phys. (2008)  
Y. Zhang *et al.*, Nat. Phys. (2009)

- Overall charge neutrality cannot be reached in Gr/ SiO<sub>2</sub>.
- Graphene response to disorder itself carries the signature of Dirac fermions

# Charge disorder in graphene



**Gate-tunable carrier density**

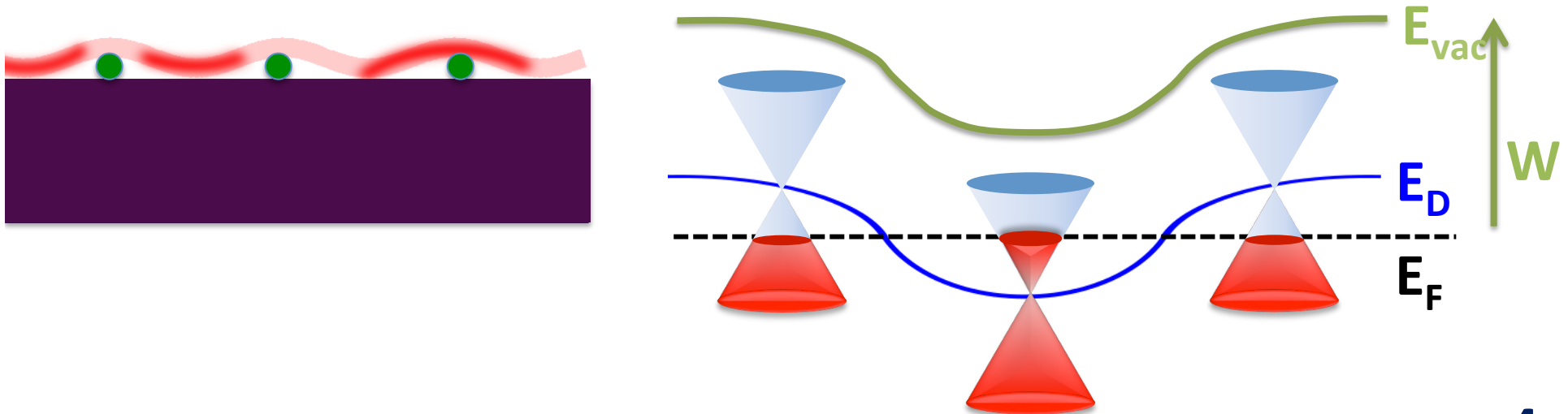
$$E_F - E_D \propto \sqrt{n} \propto \sqrt{V_g - V_g^0}$$

**Thomas-Fermi screening (2D)**

$$q_{TF} \propto DOS \quad (\propto \sqrt{n})$$

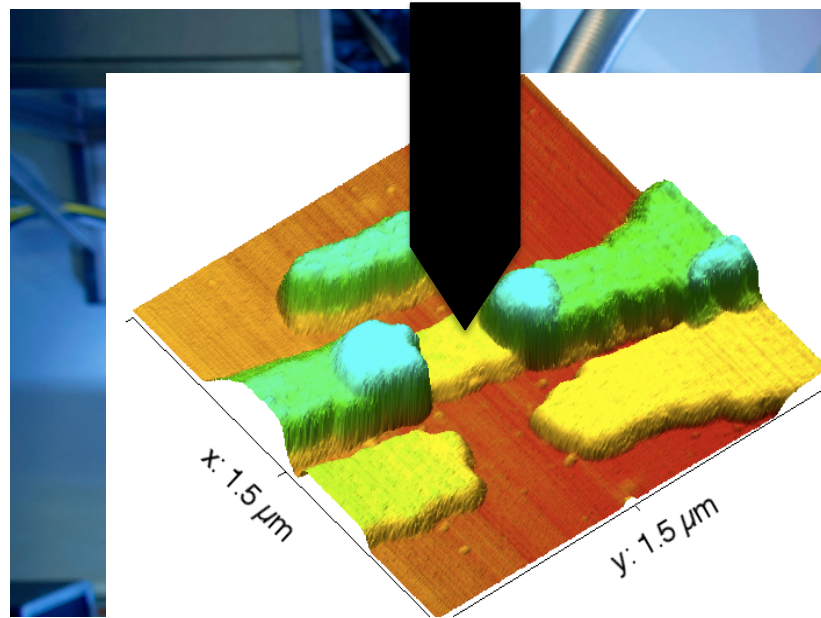
# Outline

- Nanoscale mapping of charge puddles in graphene
- Doping disorder in decoupled graphene on a metallic substrate
- Doping disorder in a graphene device
- Doping versus work function in graphene

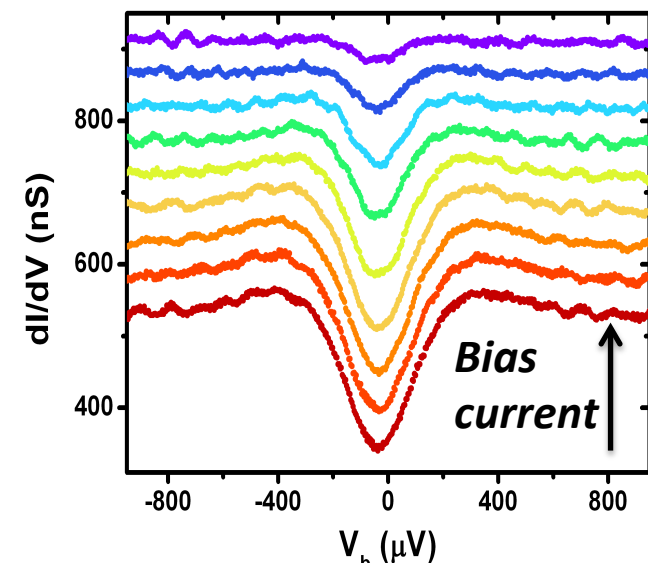
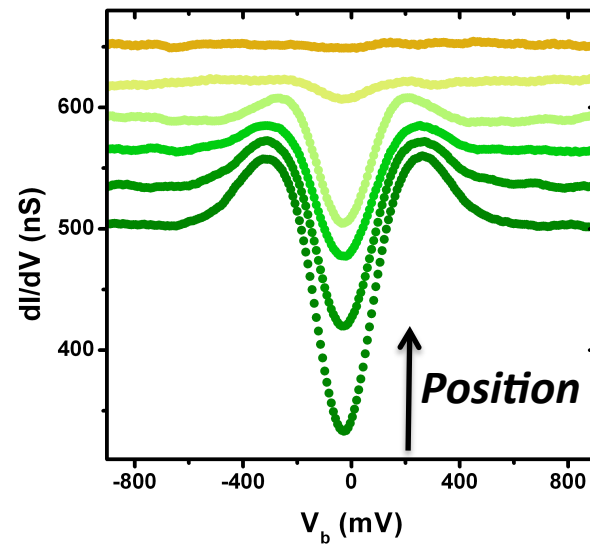
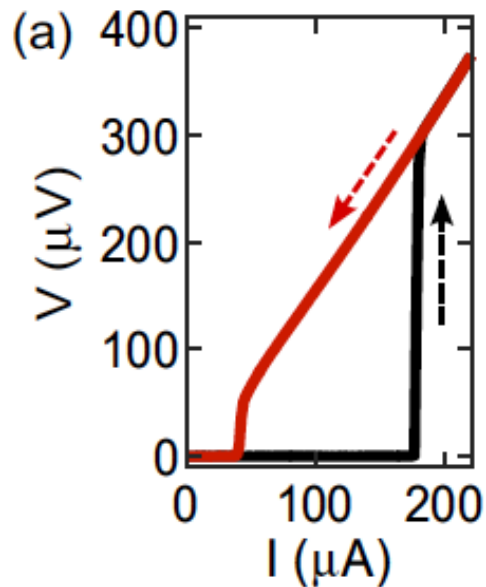




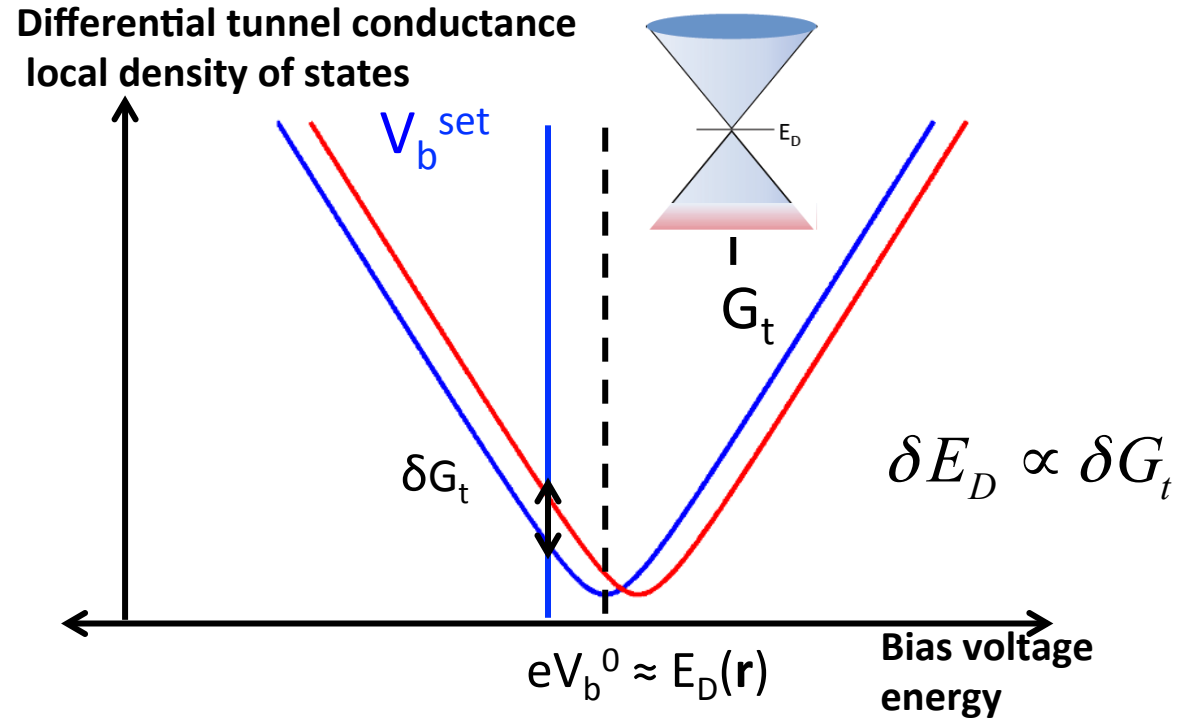
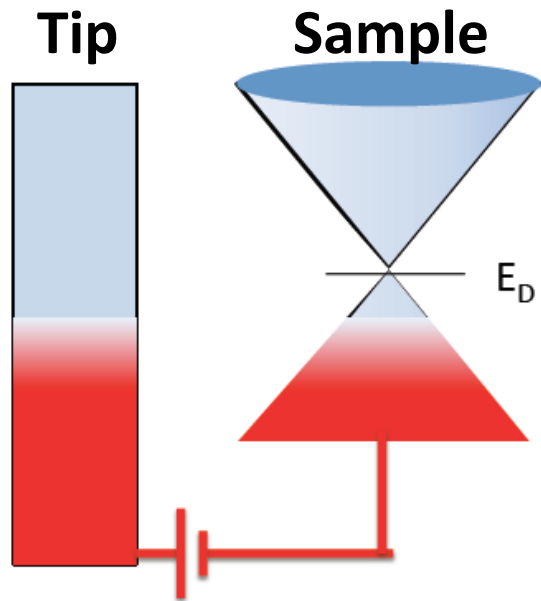
# Hybrid cryogenic scanning probe microscope



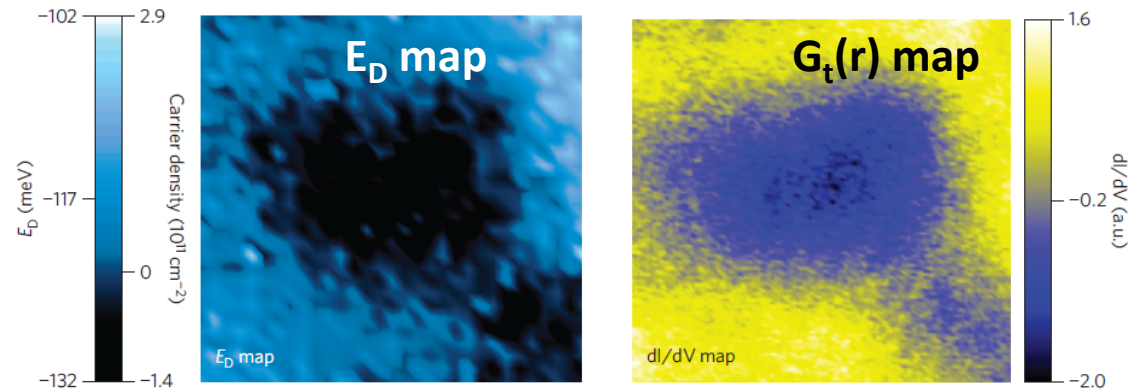
- AFM
- STM
- Transport
- Coarse sample displacement
- $T = 100 \text{ mK}$
- $B = 2 \text{ T}$
- *No prep chamber...*



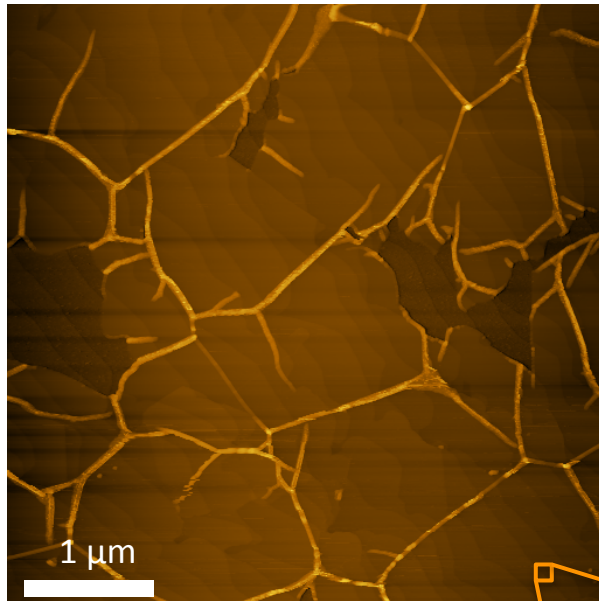
# Puddles mapping



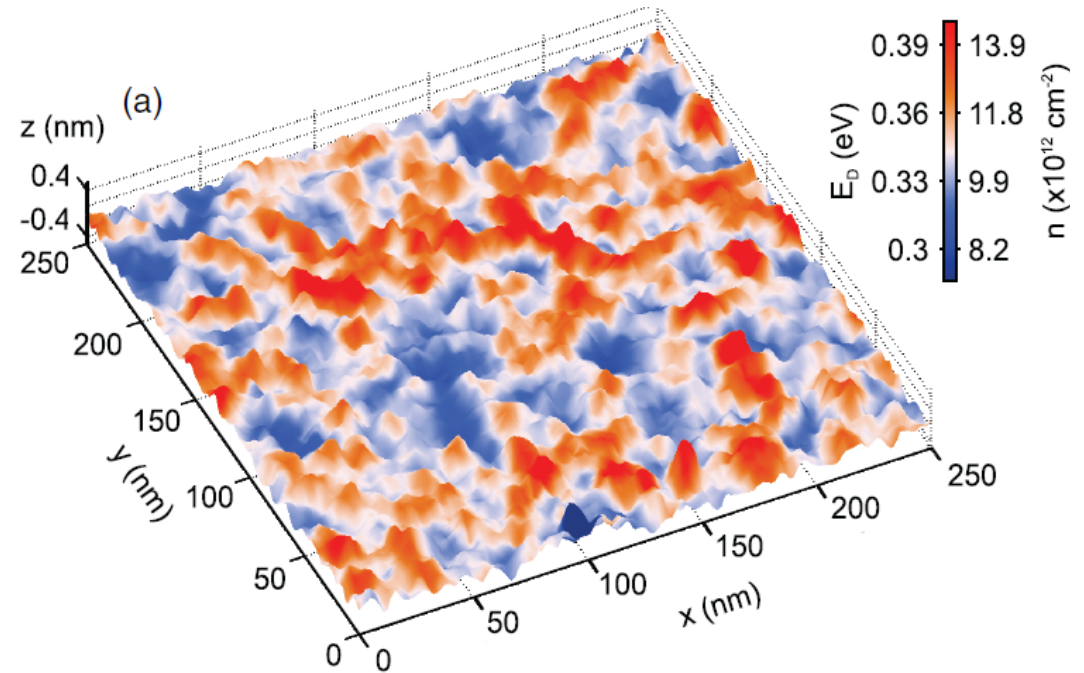
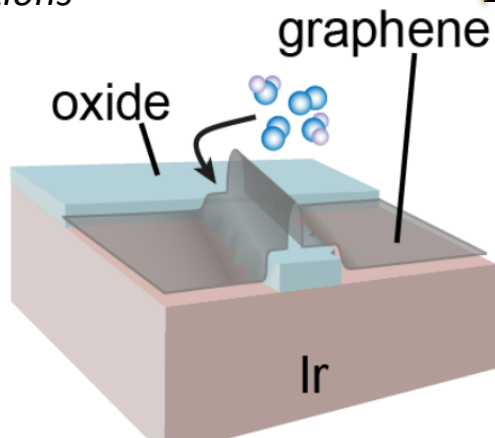
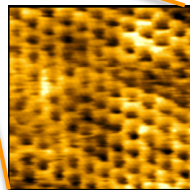
Zhang et al., *Nat. Phys.* (2009)



# Decoupled graphene on a metallic substrate



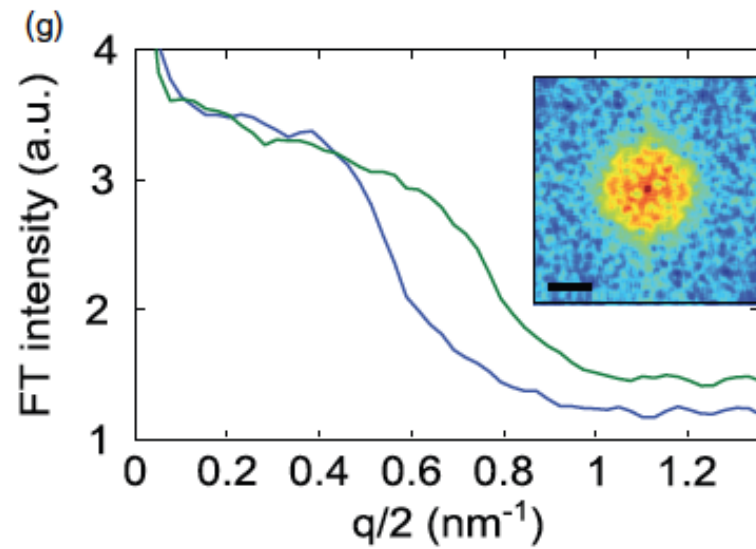
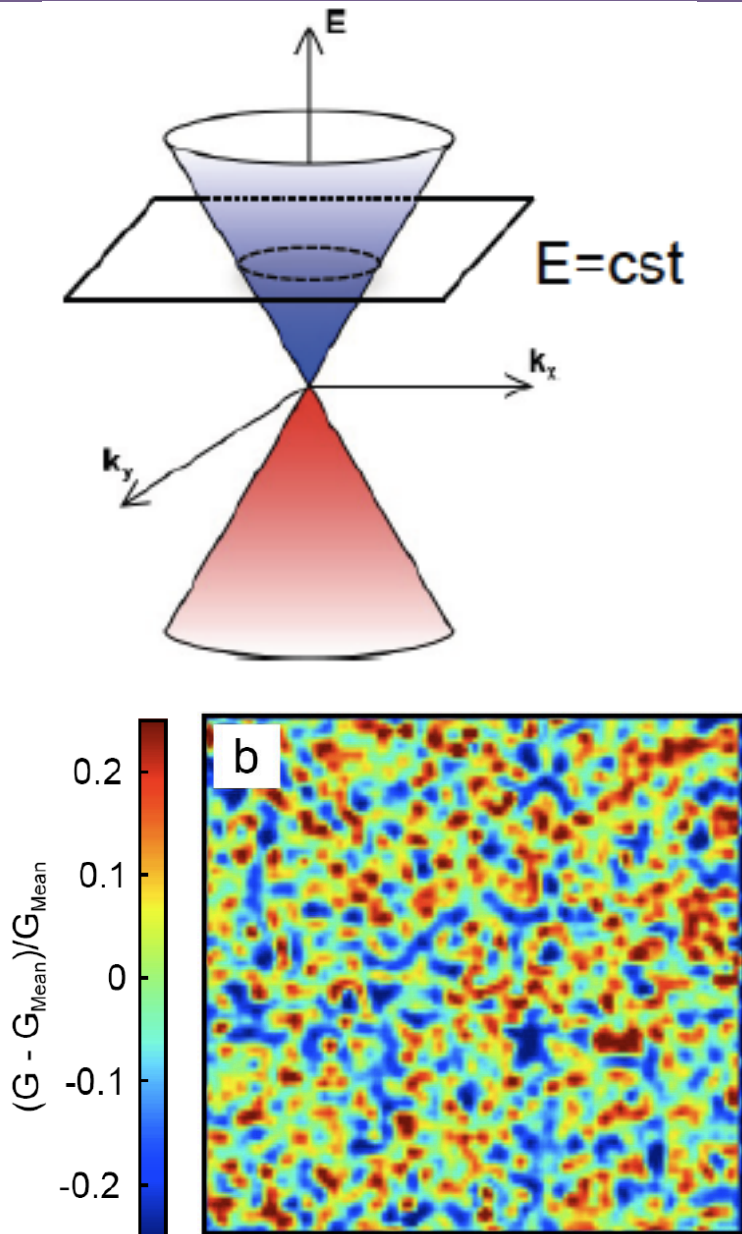
- CVD-grown single layer graphene on Ir(111)
- Exposed to ambient conditions



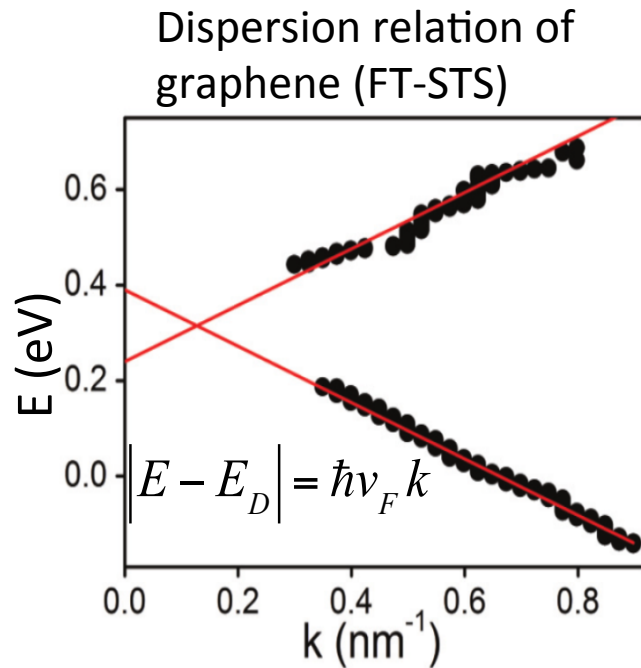
- Strong  $p$ -doping
- Diffusion of oxygen along graphene wrinkles: Intercalation
- Positive  $E_D$  vs.  $z$  correlations

Kimouche *et al.*, Carbon (2014)  
Martin *et al.*, Phys. Rev. B (2015)

# Fourier Transform STS



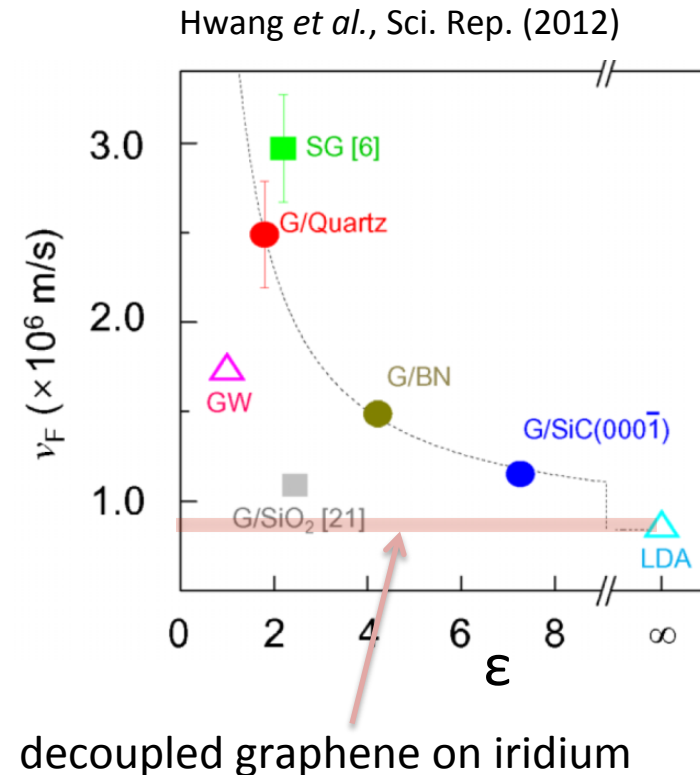
# Fermi velocity renormalization: signature of strong screening



- Fermi velocity:  
 $v_F = 0.9 \pm 0.04 \times 10^6 \text{ m.s}^{-1}$

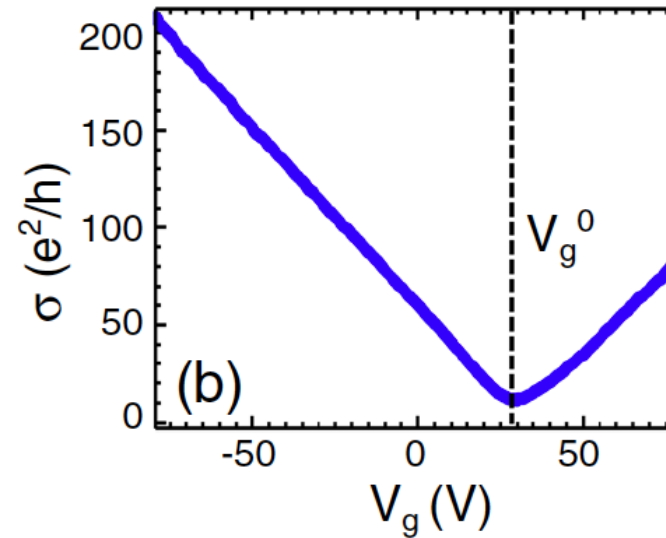
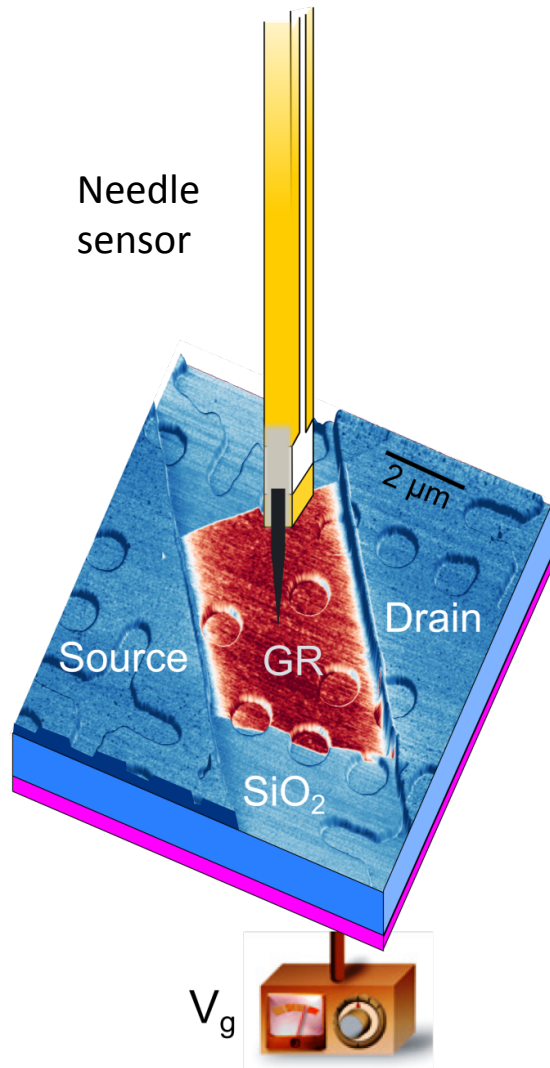
- Strong screening environment: metallic substrate about 1 nm below

Martin *et al.*, Phys. Rev. B (2015)





# Charge disorder in a graphene device: transport properties



- Resist-free microfabrication

- Transport properties

mobility:

$$\mu = 6000 \text{ cm}^2\text{V}^{-1}\text{s}^{-1}$$

substrate charge impurity density:

$$n_i = 8 \cdot 10^{11} \text{ cm}^{-2}$$

residual charge carrier density:

$$n^* = 5 \cdot 10^{11} \text{ cm}^{-2}$$

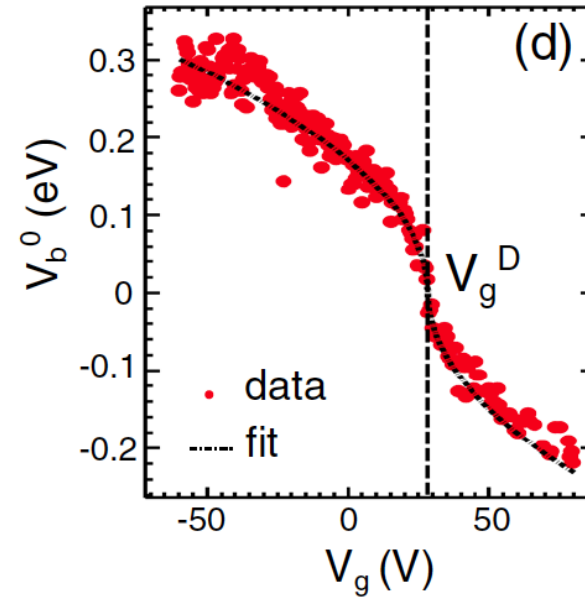
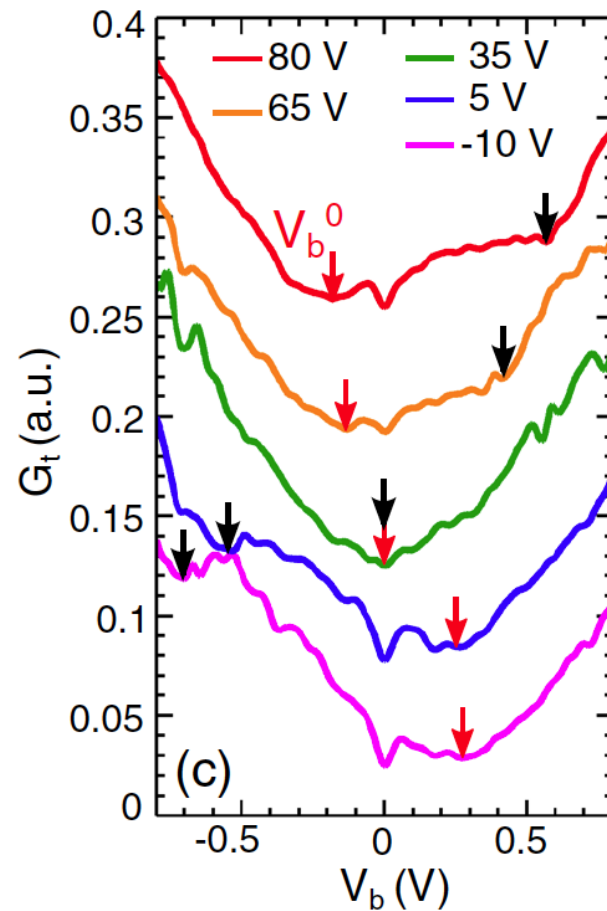
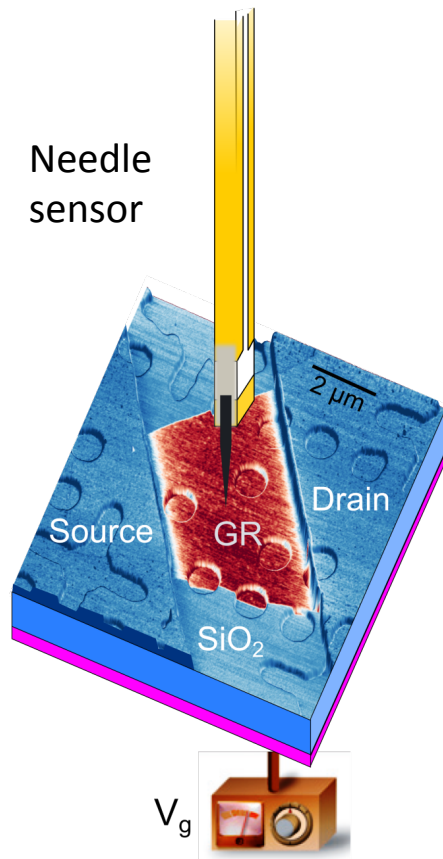
graphene-impurity distance:

$$d \approx 0.5 \text{ nm}$$

Theory: RPA – Boltzmann formalism

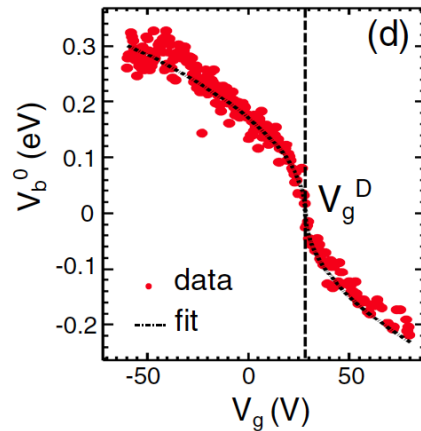
Adam *et al.*, PNAS (2007), Das Sarma *et al.*, Rev. Mod. Phys. (2011)

# Gate dependence of the local Dirac point

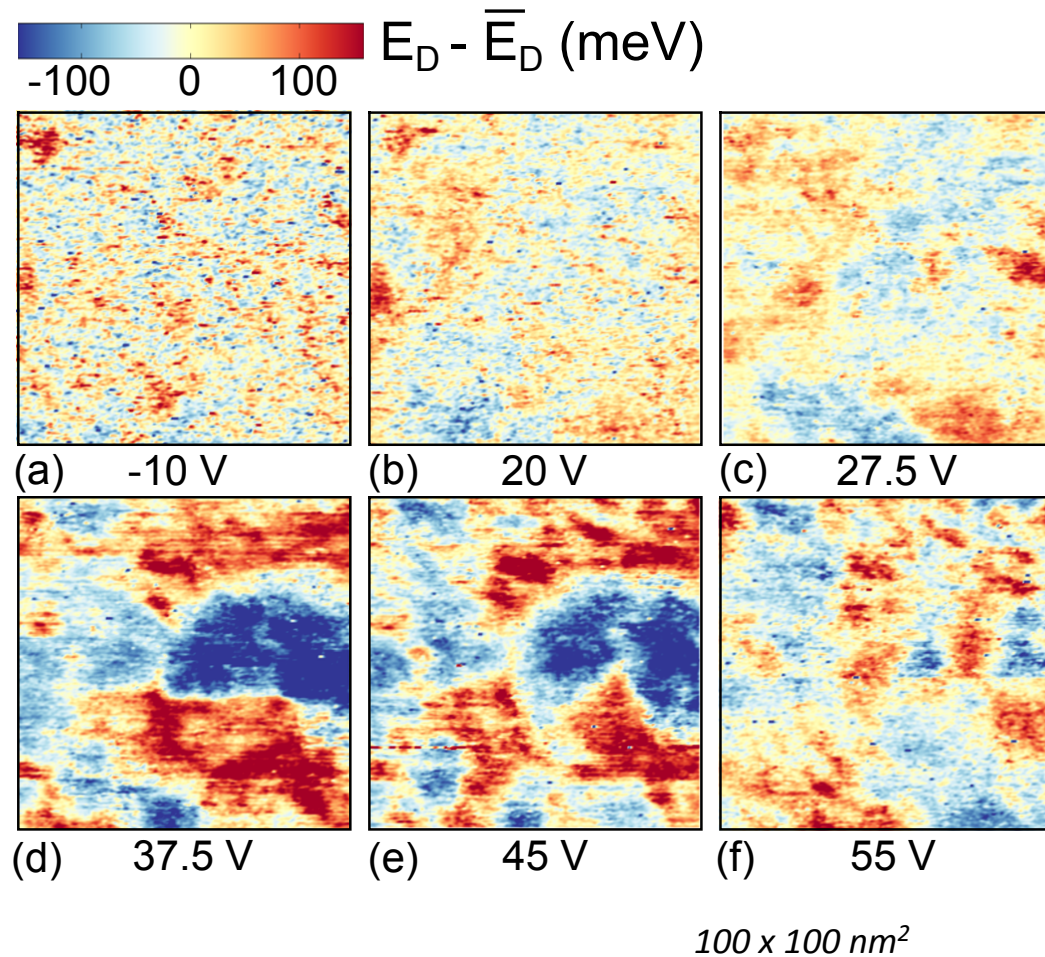


Tunneling spectroscopy:  
Gate-dependent local  
Dirac point

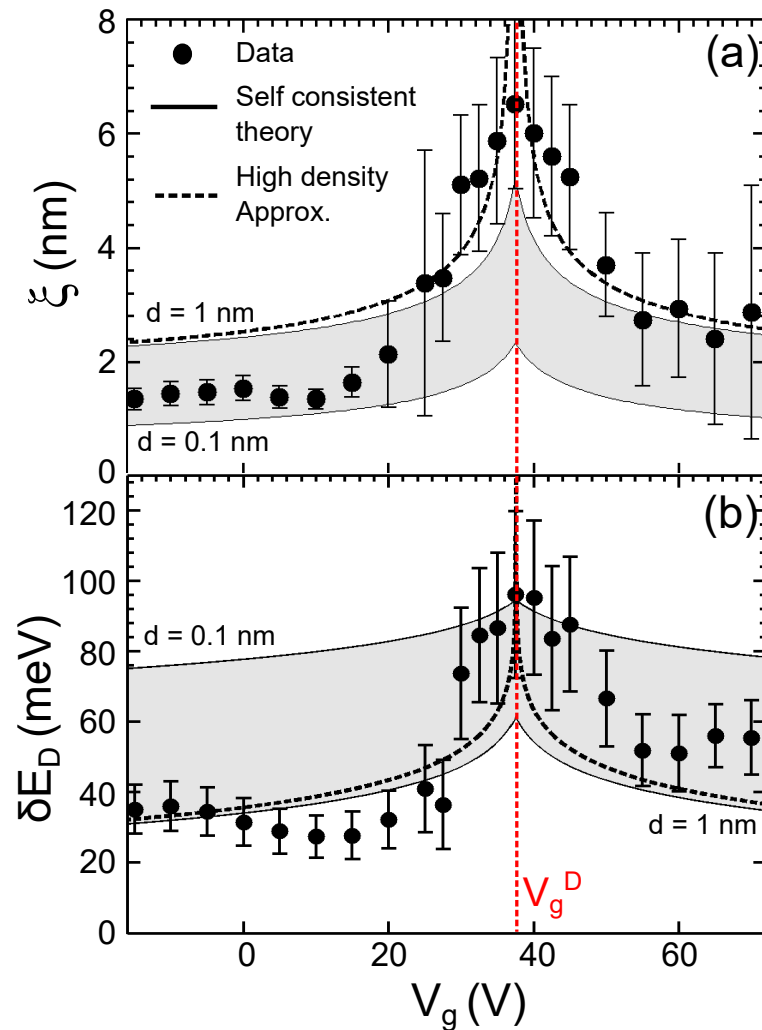
# Puddle maps at variable charge carrier density



- Puddle maps as a function of  $V_g$
- Marked maximum of puddles' size and amplitude.
- Overall charge neutrality at  $V_g = 38 \text{ V} \neq V_g^0 = 29 \text{ V}$   
 → gating by the tip.



# Charge puddles near the Dirac point



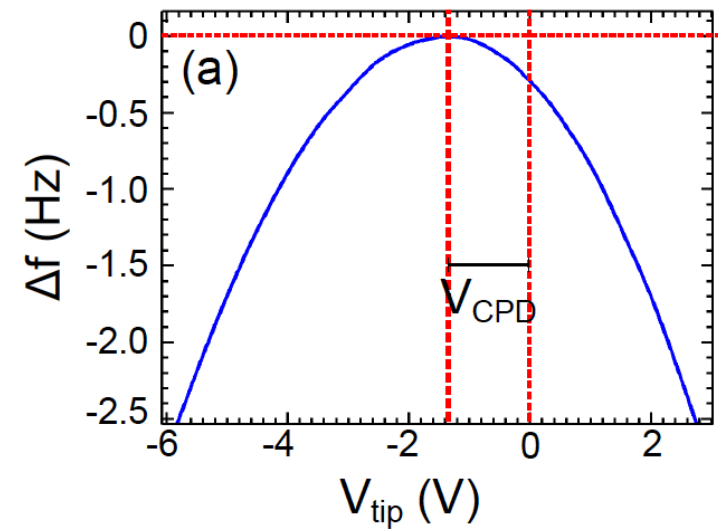
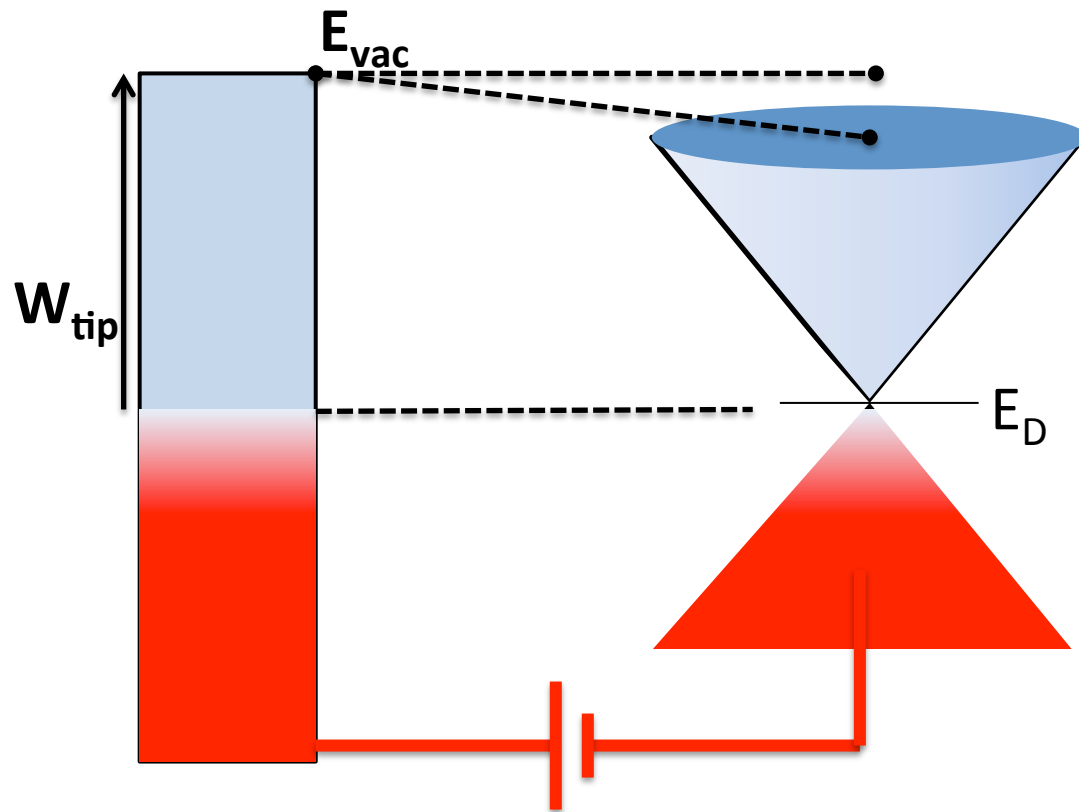
- Strong increase of puddles' **size** and **amplitude** near Dirac point.

$$\xi \propto q_{TF}^{-1} \propto n^{-1/2}$$

- Good agreement with self-consistent screening theory ( $\mu$ scopic parameters from transport measurements).
- At finite charge disorder there is screening even at the Dirac point.

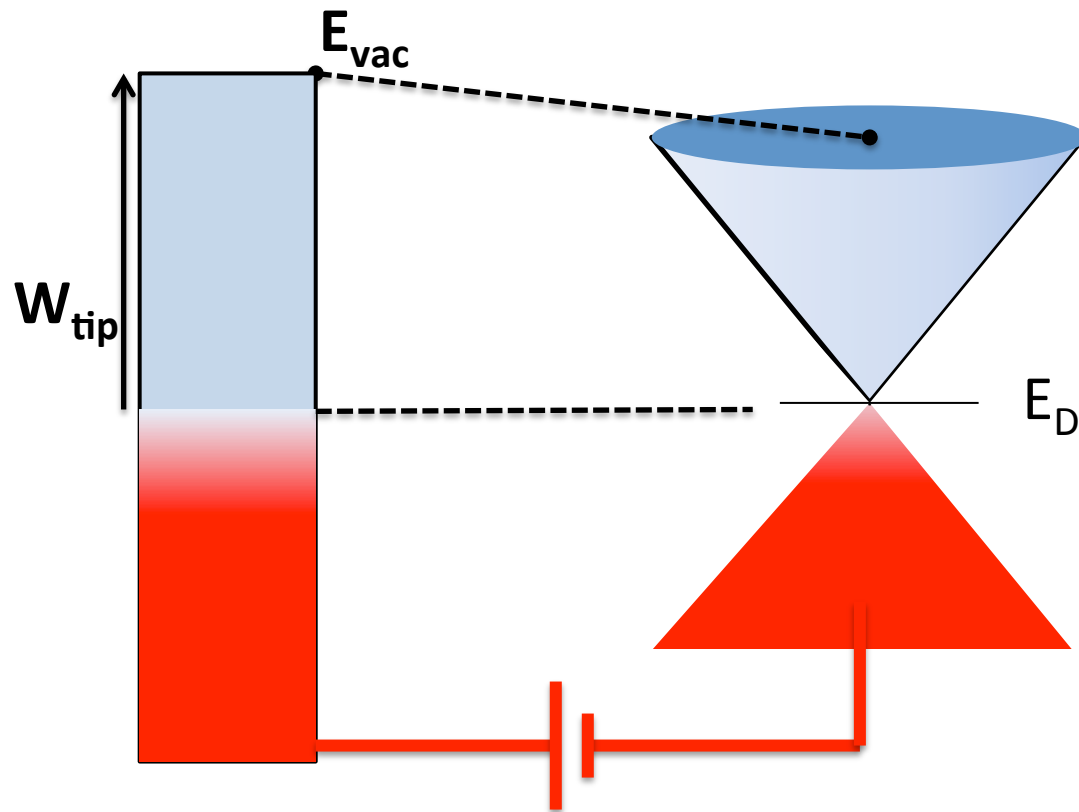
S. Samaddar *et al.*, Phys. Rev. Lett. (2016).

# Work function vs. Fermi level

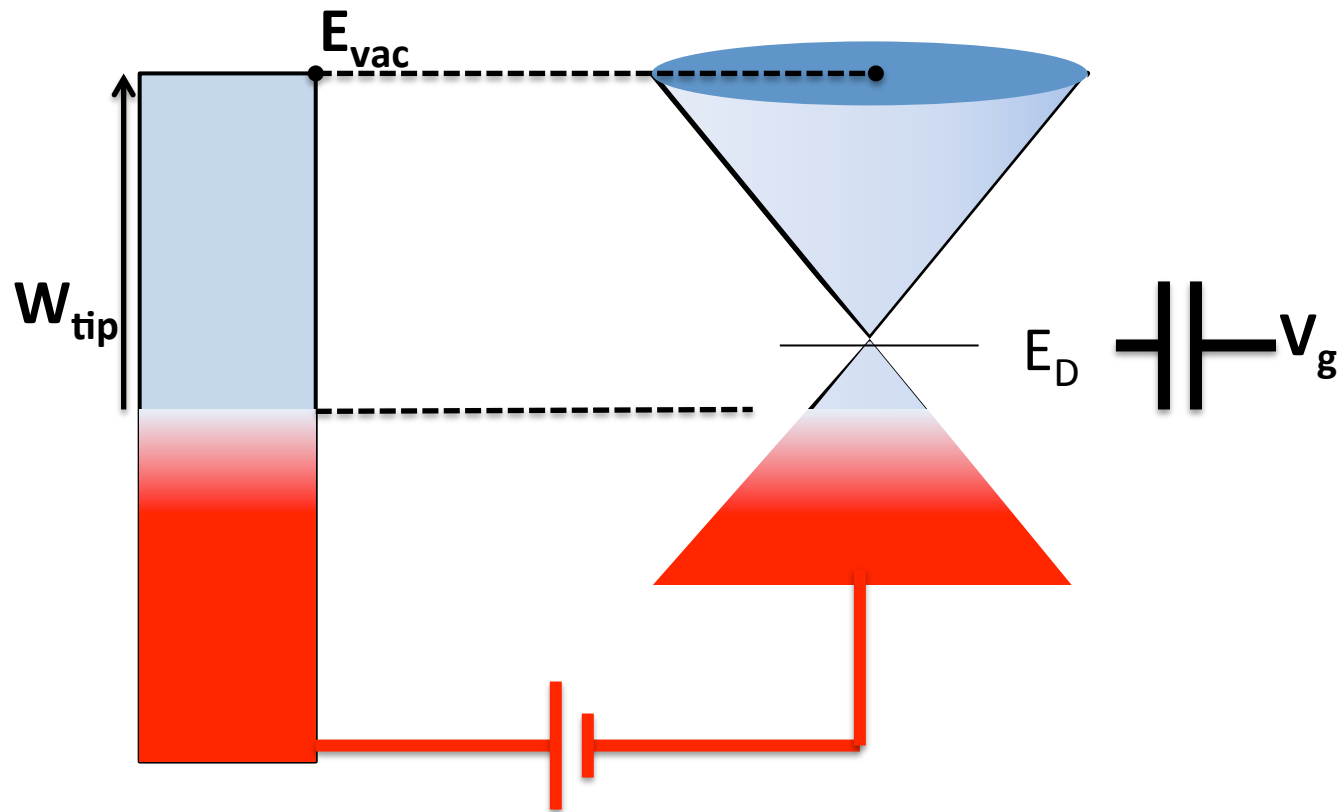




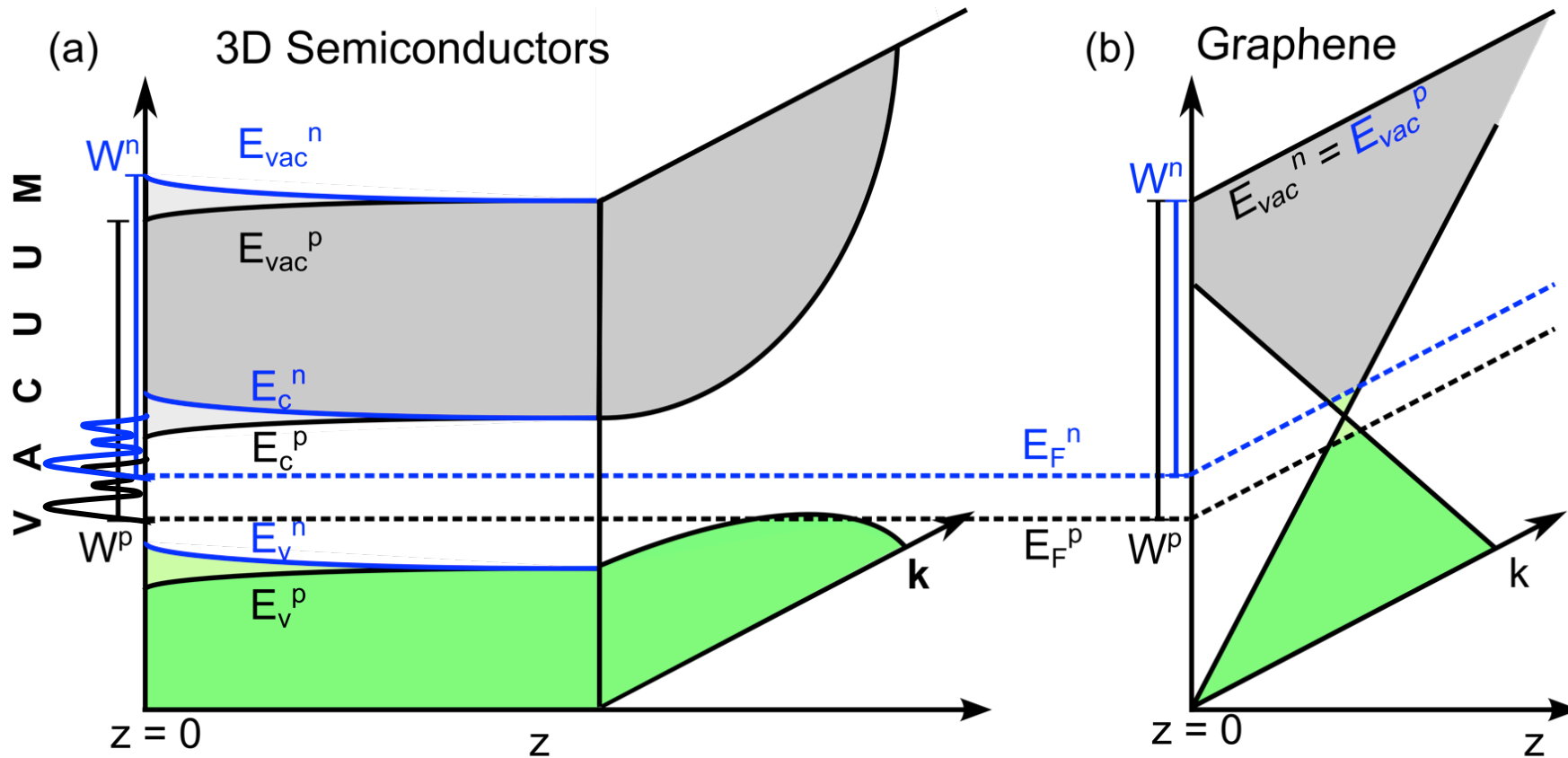
# Work function vs. Fermi level



# Work function vs. Fermi level



# Work function: semiconductor vs. graphene

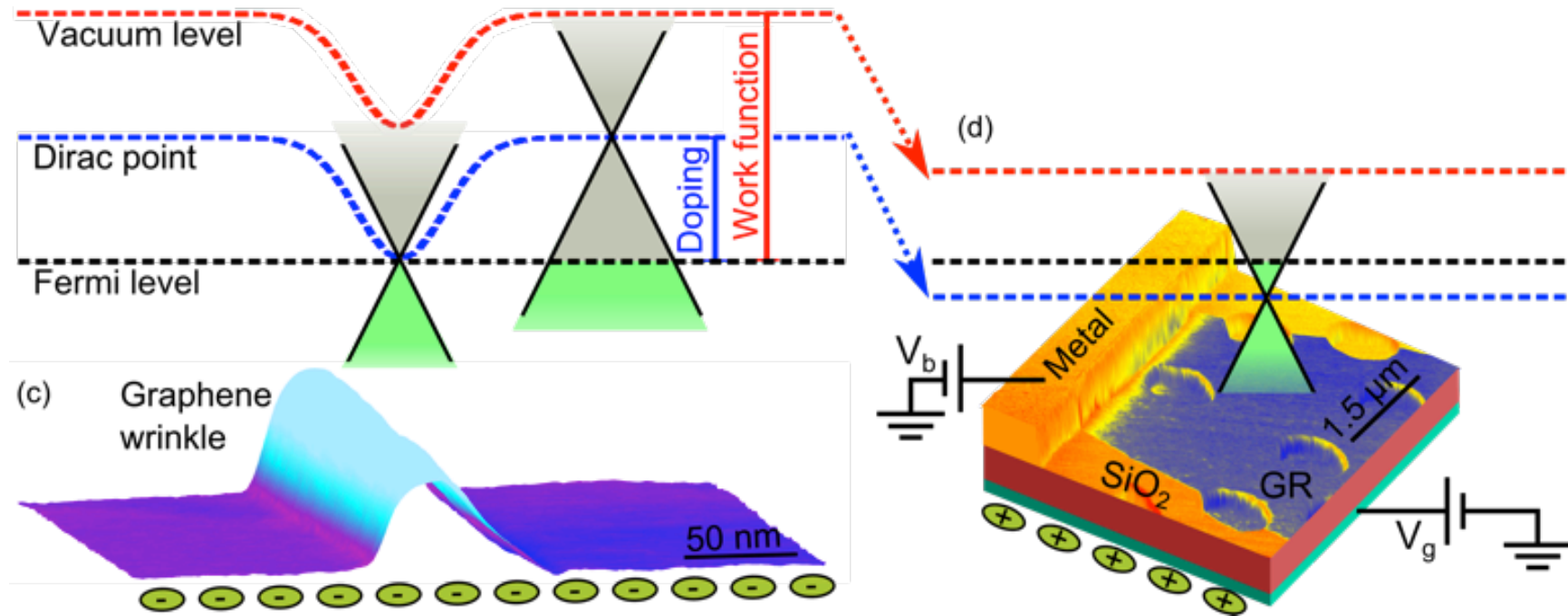


At surface:  $\frac{\partial W_{semicon}}{\partial(E_0 - E_F)} \ll 1$

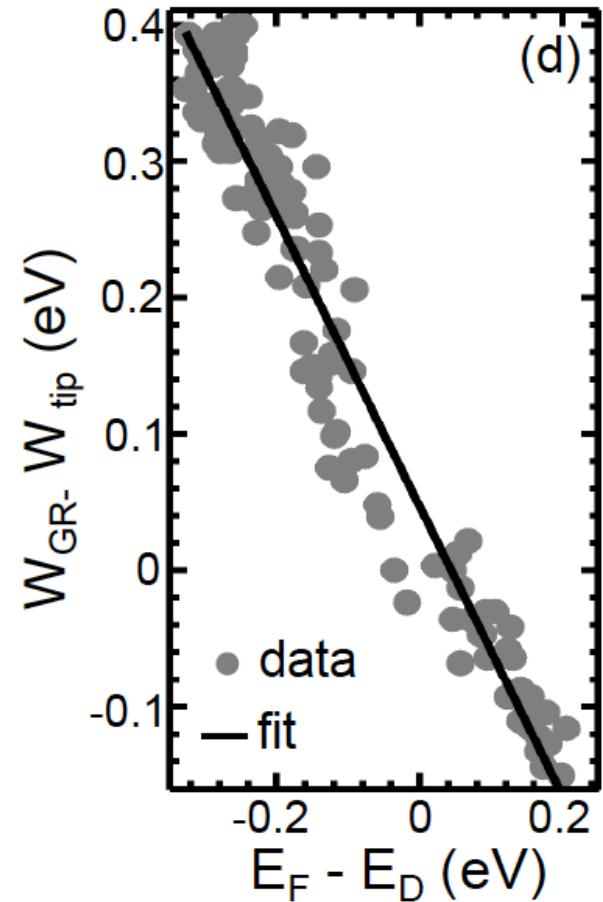
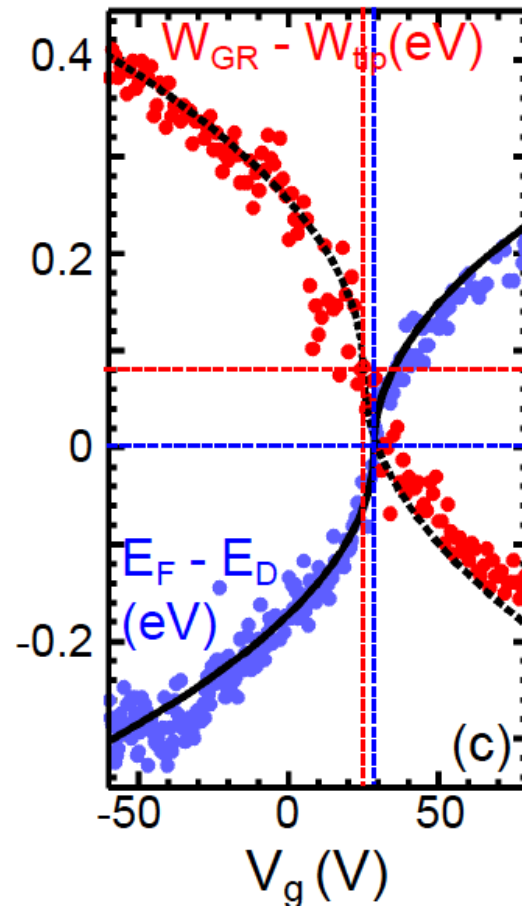
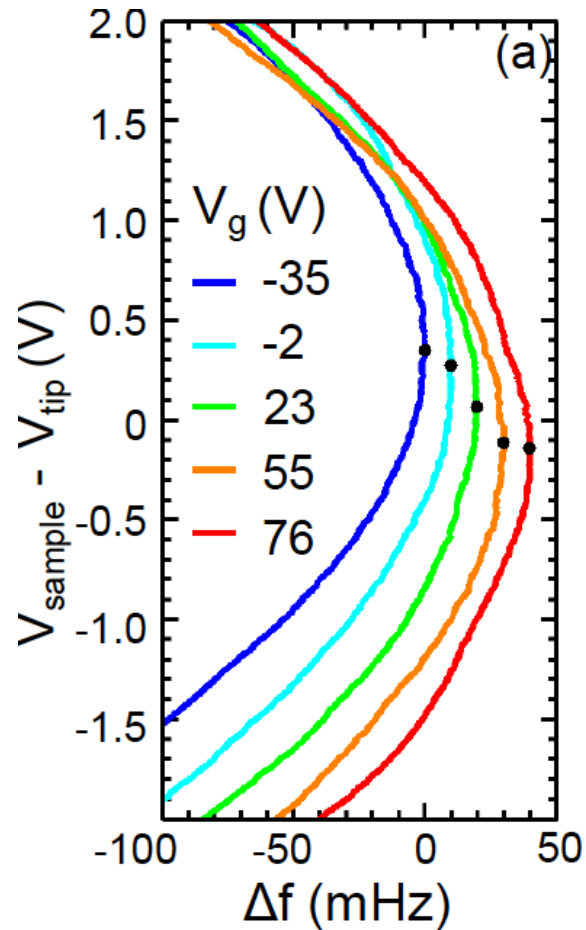
$\frac{\partial W_{graphene}}{\partial(E_D - E_F)} = 1$

Mönch, *Semiconductor surfaces and interfaces* (1987)

# Work function: semiconductor vs. graphene



# Work function vs. doping level in gated graphene



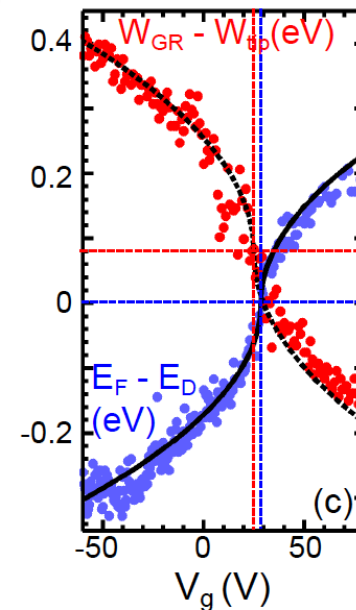
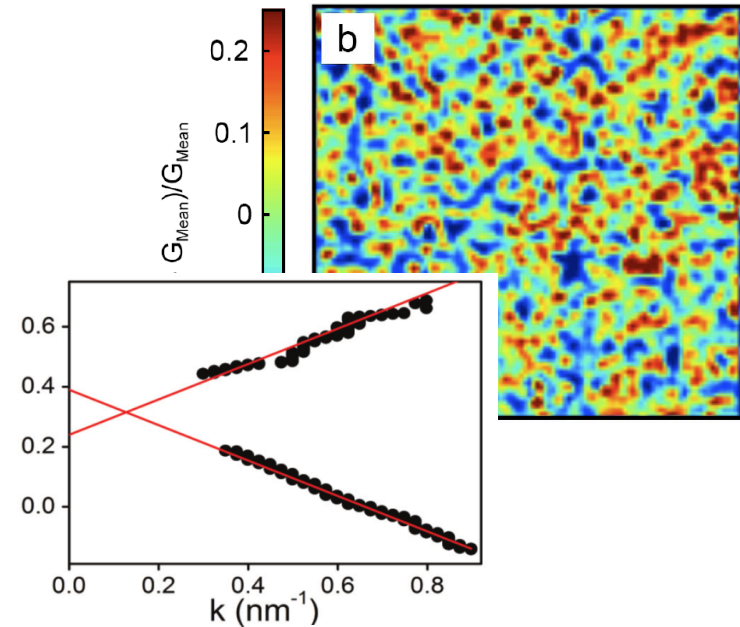
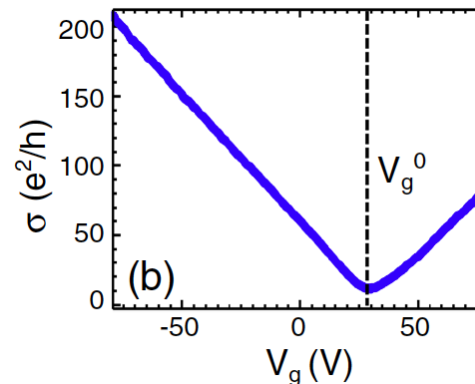
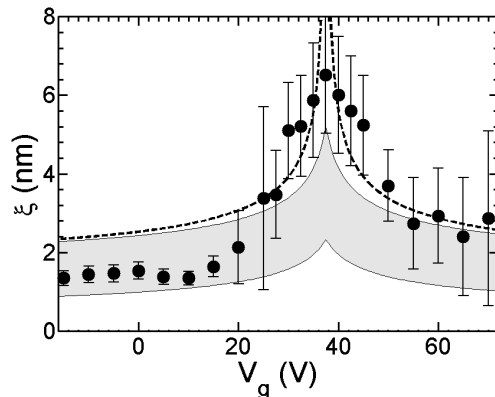
See also:  
Yu et al., Nanolett. (2010).

$$\frac{\partial W_{\text{graphene}}}{\partial (E_D - E_F)} = 1$$



# Summary

- Local and global properties  
*in situ* probing of *microscopic* device properties
- Graphene response to charge disorder:
  - probe of e-e interactions
  - strong growth of doping inhomogeneities near charge neutrality



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Nanofab

Cryogenics

Electronics

Lab

